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Respectfully submitted,



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Substitute for form 1449B/PTO

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1

of 1

Application Number

10/036,321

Filing Date

December 26, 2001

First Named Inventor

Stevens, et al.

Group Art Unit

1734

Examiner Name

Laura E. Edwards

Attorney Docket Number

AMAT/6120/CMP/ECP/RKK

Submission Date

June 1, 2004

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
	C1	Verteq Online Products Overview, www.verteq.com	
	C2	Censak, R.J., et al., "Spin Basket," IBM Technical Disclosure Bulletin, Vol. 18, No. 8, pp. 2476-77, 1/1976	
	C3	Singer, P., "Wafer Processing," Semiconductor International, "Non-Uniformity of Copper Electroplating Studied", p. 70, 6/1998	
	C4	Colombo, L., "Wafer Back Surface Film Removal," Spin Etch Technology, Central R&D, SGS-Thomson Microelectronics, Agrate, Italy, 6 pp.	
	C5	©Semitool Inc., "Metallization & Interconnect," 1998, 4 pp.	
	C6	Laurell Technologies Corporation, "Two Control Configurations Available – see WS-400 or WS-400-Lite," 10/19/1998, 6 pp.	
	C7	Singer, P., "Tantalum, Copper and Damascene: The Future of Interconnects," Semiconductor International, June 1998, Pages cover, 91-92, 94, 96 & 98	

Examiner

Date Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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